



Docket No.: 283244US0PCT

ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/562,868

Applicants: Anne DURANDEAU, et al.

Filing Date: January 4, 2007

For: METHOD FOR DEPOSITION OF TITANIUM OXIDE BY A
PLASMA SOURCE

Group Art Unit: 1792

Examiner: Gambetta

SIR:

Attached hereto for filing are the following papers:

Restriction Response

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of \$0.00 to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)
(OSMMN 02/09)

Benjamin A. Vastine, Ph.D.
Registration No. 64,422